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APR -3 2002

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TC 2800 MAIL ROOM

In re: application of

Toshiro HAYAKAWA, et al.

Application No. 09/315,068

Confirmation No.: 5982

Filed: May 20, 1999

Group Art Unit: 2828

Examiner: Jeffrey N. Zahn

#15 / Notice  
of  
Appeal  
Marsha  
4/1/02

For: SEMICONDUCTOR LASER AND METHOD OF MANUFACTURING THE SAME

### NOTICE OF APPEAL

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the final Office Action dated November 1, 2002.

A check for the statutory fee of \$320.00 is attached. Please charge or credit any difference or overpayment to Deposit Account No. 19-4880. A duplicate copy of this sheet is enclosed.

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320.00 OP

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Date: April 1, 2002

Respectfully submitted,

*David A. Klein*

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